

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

NAGAHAMA et al

Serial No. 09/500,288

Filed: February 8, 2000

For: NITRIDE SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD



Atty. Ref.: 925-179

Group: 2824

Examiner: Wilson

RECEIVED  
MAY 24 2001  
Technology Center 2100

\* \* \* \* \*

May 22, 2001

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

Responsive to the Official Action of April 26, 2001, paper no.15, and the requirement for restriction presented in it, applicants elect the subject matter of Group I, that is claims 1 to 6 directed to a semiconductor device.

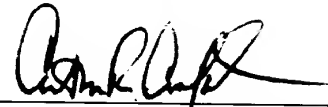
Please examine the elected claims taking into account the Information Disclosure Statements filed May 10, 2000 (received May 22, 2000), September 8, 2000 and the one filed concurrently with this Response.

- **NAGAHAMA** et al  
Serial No. **09/500,288**

Respectfully submitted,

**NIXON & VANDERHYE P.C.**

By: \_\_\_\_\_



Arthur R. Crawford  
Reg. No. 25,327

ARC:pfc  
1100 North Glebe Road, 8th Floor  
Arlington, VA 22201-4714  
Telephone: (703) 816-4000  
Facsimile: (703) 816-4100